

Docket: 740756-1998

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Shunpei YAMAZAKI et al.)
Serial No. 09/352,194 APR 1 0 2002) Art Unit: 2823
Filed: July 13, 1999) Examiner: F. Toledo
For: CRYSTALLINE SEMICONDUCTOR TO	HIN)
FILM, METHOD OF FABRICATING T	HE .)
SAME, SEMICONDUCTOR DEVICE, A	AND)
METHOD OF FABRICATING THE SAI	ME) Date: April 10, 2002

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents and Trademarks Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of these references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,

Eric J. Robinson Registration No. 38,285

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